

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 8729

Naomi NISHIKI et al.

Docket No. 2000-1751A

Serial No. 09/742,390

Group Art Unit 2879

Filed December 22, 2000

Examiner Dalei Dong

SHADOW MASK ASSEMBLY MANUFACTURING METHOD AND CATHODE RAY TUBE MANUFACTURING METHOD

KECENED AMB 2800 SER 17 AMB 2800 TECHNOLOGY CENTER 2800 THE COMMISSIONER IS AUTHO TO CHARGE ANY DEFICIENCY | FEES FOR THIS PAPER TO DEPO ACCOUNT NO. 23-0975

## **PETITION FOR EXTENSION OF TIME**

**Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of March 12, 2003.

The fee of \$930.00 is

- (X) submitted herewith.
- to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is 0 enclosed.
- Small entity status of this application is established by a Small Entity Status Assertion () which
  - 0 is enclosed.
  - () has been previously submitted.

09/15/2003 CNGUYEN 00000137 09742390

01 FC:1253

930.00 OP

Respectfully submitted,

Naomi NISHIKAlet al

W. Douglas Hahm Registration No.44,142 Attorney for Applicants

WDH/gtg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 September 12, 2003